

Information Disclosure
Statement by Applicant



Application Number: 10/059,780
 Filing Date: 01/29/2002
 First Named Inventor: X. Bian
 Group Art Unit: 1773
 Examiner: n.a.
 Atty. Docket Num.: SJO920000130US2

U.S. Patent Documents

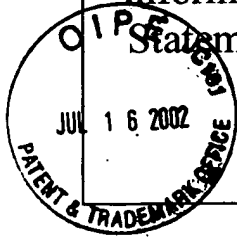
Examiner Initials	Cite No.	U.S. Patent Document Number	Kind Code	Name of Patentee or Applicant	Publication Date mm-dd-yyyy	Pages, columns, lines where relevant information appears
HCL ↓	A	5,789,056		Bian, et al.	08-04-1998	
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	J3	JP	11328646		Suekane, et al.	11-30-1999	
	J4	JP	11110733		Kanazawa, et al.	04-23-1999	
	J5	JP	363187416		Hitachi KK	08-03-1988	
	J6	JP	60076016		Matsuzaki, et al.	04-30-1985	

Examiner Signature	<i>H. H. H.</i>	Date Considered	9/26/03
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Sheet 2 of 2

OTHER PRIOR ART – NON-PATENT LITERATURE

Examiner Initials	Cite No.	Citation: Author (in capital letters), title, book, symposium, etc.	
Hll	AA	T.D.LEE, et al. "A Double Underlayer for Co-Based Longitudinal Recording Thin Film Media," IEEE Transactions on Magnetics, vol. 35, no. 5, September 1999, pp. 2628ff.	
Hll	BB	T.P.NOLAN, et al., "Independent Optimization of Nucleation and Growth Processes of Titanium-alloy Underlayers for Cobalt-alloy Perpendicular Recording Media," Materials Research Soc. Symp. Process. Vol. 403, 1996, pp. 713ff.	
Hll	CC	T.KANBE, et al., "Effects of underlayer grain size on the microstructure of the magnetic layer in CoCrPt media," IEEE Transactions on Magnetics, vol. 35, no. 5, September 1999, pp. 2667ff.	
Hll	DD	M.MIRZAMAANI, et al., "Recording Performance of Thin Film Media With Various Crystallographic Preferred Orientations on Glass Substrates," IEEE Transactions on Magnetics, vol. 34, no. 4, July 1998, pp. 1588ff.	
Hll	EE	L.LEE, et al., "Seed layer induced (002) crystallographic texture in NiAl underlayers," J. Appl. Physical. 79(8). 15 April 1996	

Examiner Signature	<i>H. Miller</i>	Date Considered	9/25/03
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Sheet 2 of 2

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